

Notice of References Cited	Application/Control No. 09/995,187	Applicant(s)/Patent Under Reexamination CONNELL ET AL.	
	Examiner Wesley D Markham	Art Unit 1762	Page 1 of 1

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	C	US-6,144,795	11-2000	Dawes et al.	385/141
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Sara et al., "Photolithography Fabrication of Sol-Gel Ridge Waveguide", SPIE Vol. 3469, July 1998, pages 118-123
	V	Coudray et al., "Integrated optics based on organo-mineral materials", European Materials Conference, June 1999
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.